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To: Commissioner for Patents

Technology Center 1700

Facsimile Number: 571-273-8300

Total Pages Sent: 5

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Transmission Date: September 14, 2006

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant: Chen, *et al.*

Serial No: 10/650,886

Date Filed: August 28, 2003

Title: In-Situ Strip Process for Polysilicon Etching in Deep Sub-Micron Technology

Docket No.: TSM6283131RI

Art Unit: 1763

Examiner: George A. Goudreau

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- Certification of Facsimile Transmission (1 page)
- Response to Office Action (2 pages)
- Copy of documents filed June 8, 2006 (6 pages)

Respectfully submitted,

Judy A. Betts
Legal Assistant

Confirmation Respectfully Requested

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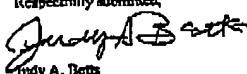
Applicant: Chen, et al.	Docket No.: TSM62823131R1
Serial No.: 10/630,866	Art Unit: 1763
Date Filed: August 28, 2003	Examiner: George A. Goodness
Title: In-Situ Strip Process for Polysilicon Etching in Deep Sub-Micron Technology	

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- Supplemental Declaration for Retained Patent Application (1 page)
- Information Disclosure Statement (2 duplicate pages)
- IDS Form PTO/88/08e (1 page) citing 8 references

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IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant:	Chen, <i>et al.</i>	Docket No.:	TSM6283131RI
Serial No:	10/650,886	Art Unit:	1763
Date Filed:	August 28, 2003	Examiner:	George A. Goudreau
Title:	In-Situ Strip Process for Polysilicon Etching in Deep Sub-Micron Technology		

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